

Copolyimides Containing Surface Modifying Groups: Competition Between Silicone and Fluorine-Containing Blocks

Christopher J. Wohl¹, Allison M. Crow², William T. Kim², Michelle H. Shanahan³, Jereme R. Doss³, Yi Lin³, John W. Connell¹

¹NASA Langley Research Center, Hampton, VA 23681

²Langley Aerospace Research Summer Scholar (LARSS), NASA Langley Research Center, Hampton, VA, 23681

³National Institute of Aerospace, Hampton, VA 23666

250th ACS National Meeting, Boston, MA

August 16-20, 2015



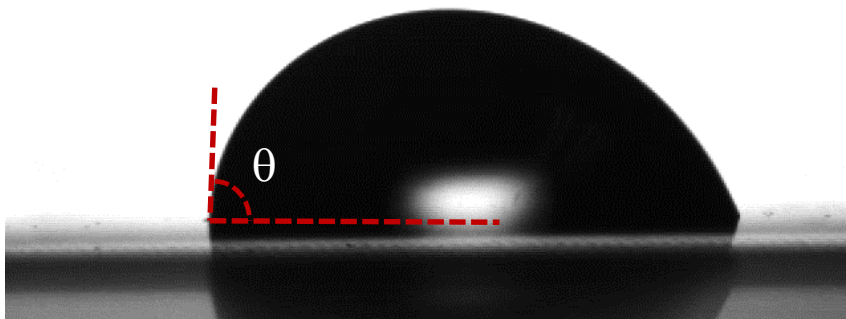
Surface Modifying Agents (SMA)s in Action



Langley Research Center

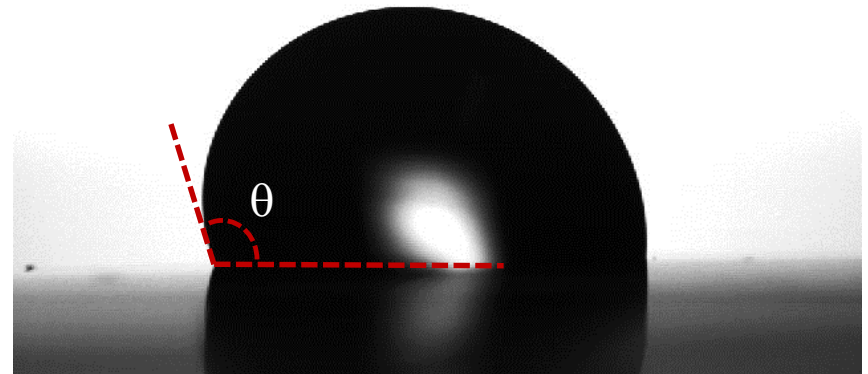
Polyimide without SMAs

89°



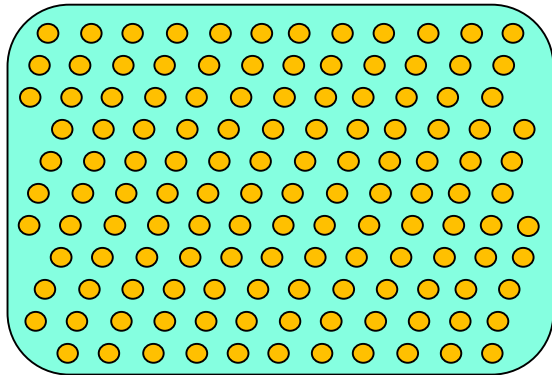
Polyimide with SMAs

116°

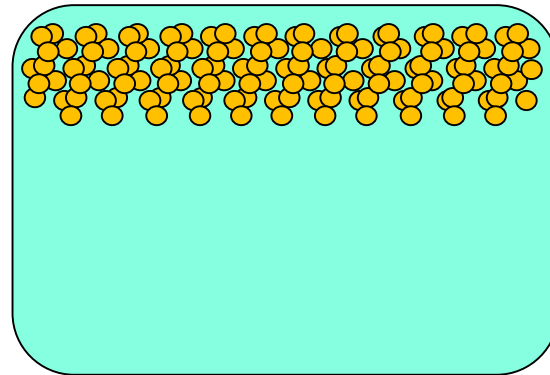


8 μL water droplet tilting axis contact angle experiment

◆ Entropy vs enthalpy



Entropically
Favorable
Distribution



Enthalpically
Favorable
Distribution

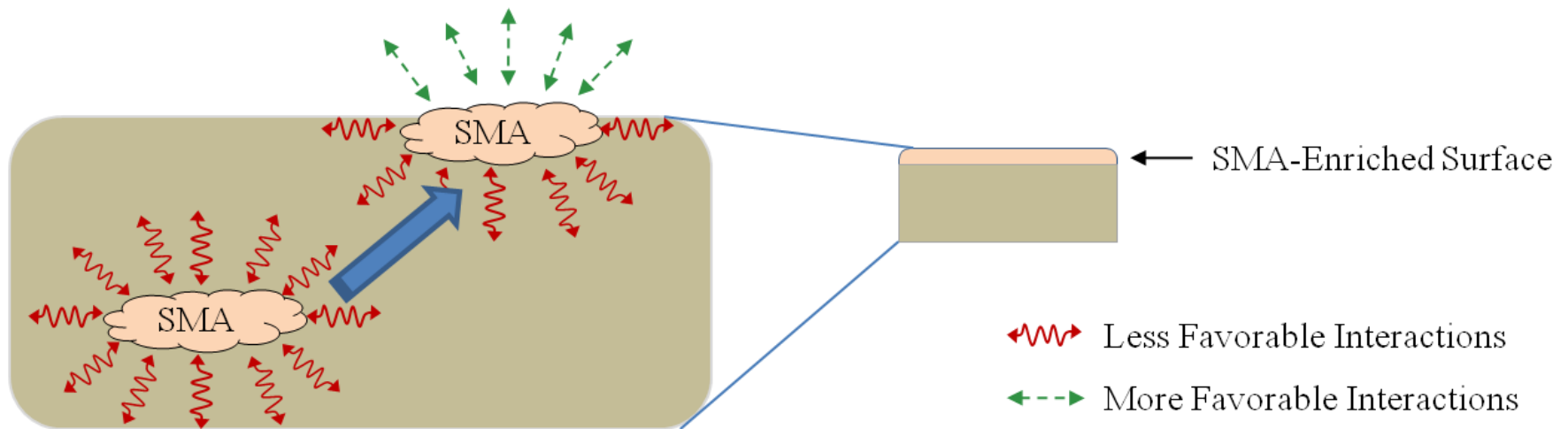
◆ Entropy vs enthalpy

Thermodynamic Response of SMA

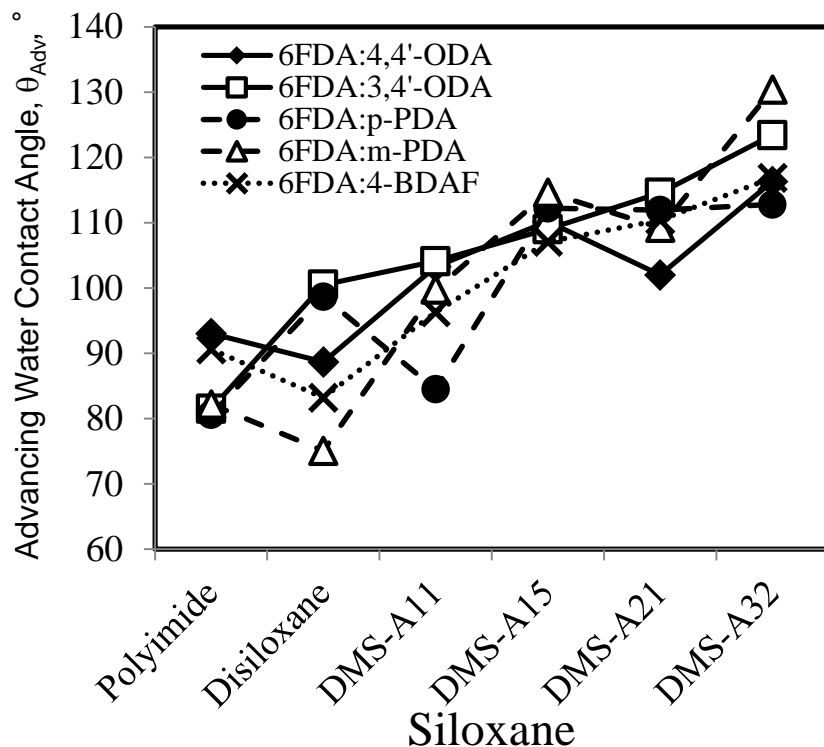


Arrows indicate enthalpy-driven migration of **LOW** and **HIGH** surface energy components

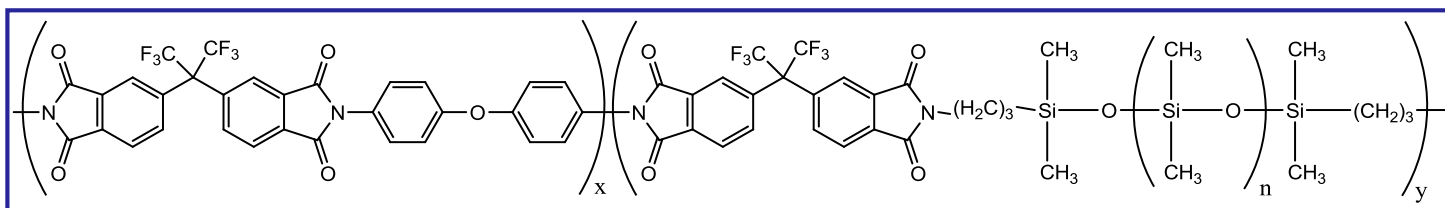
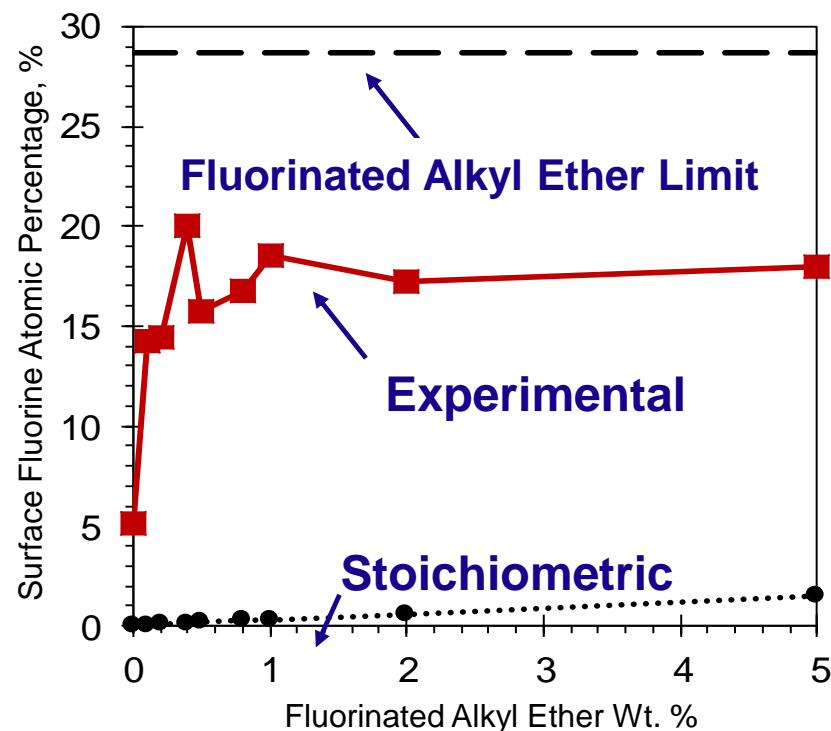
◆ Entropy vs enthalpy



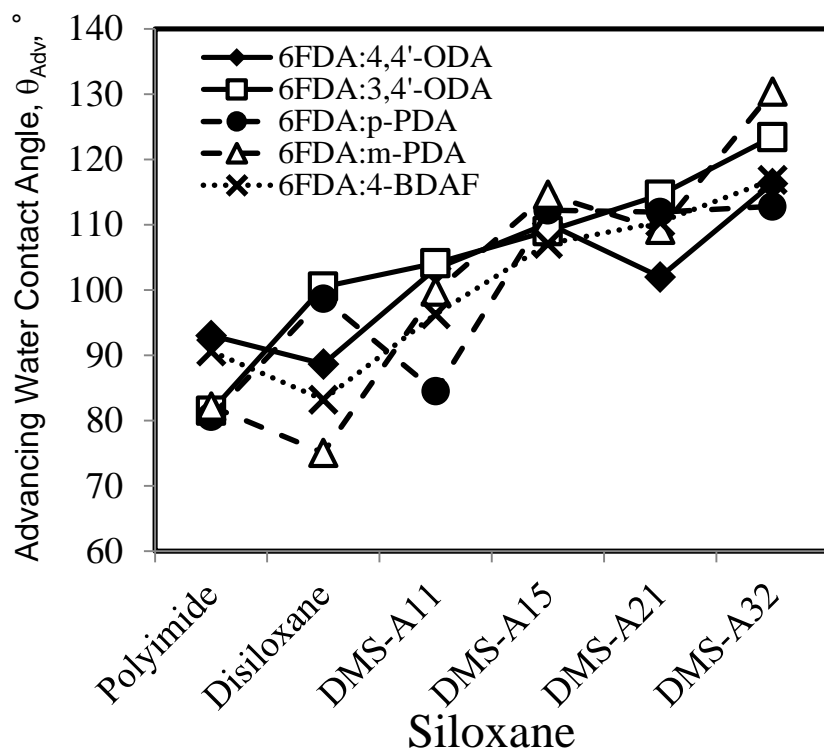
Si-containing Polyimides



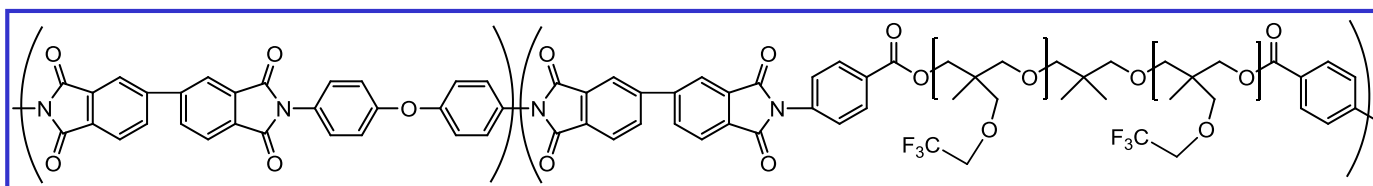
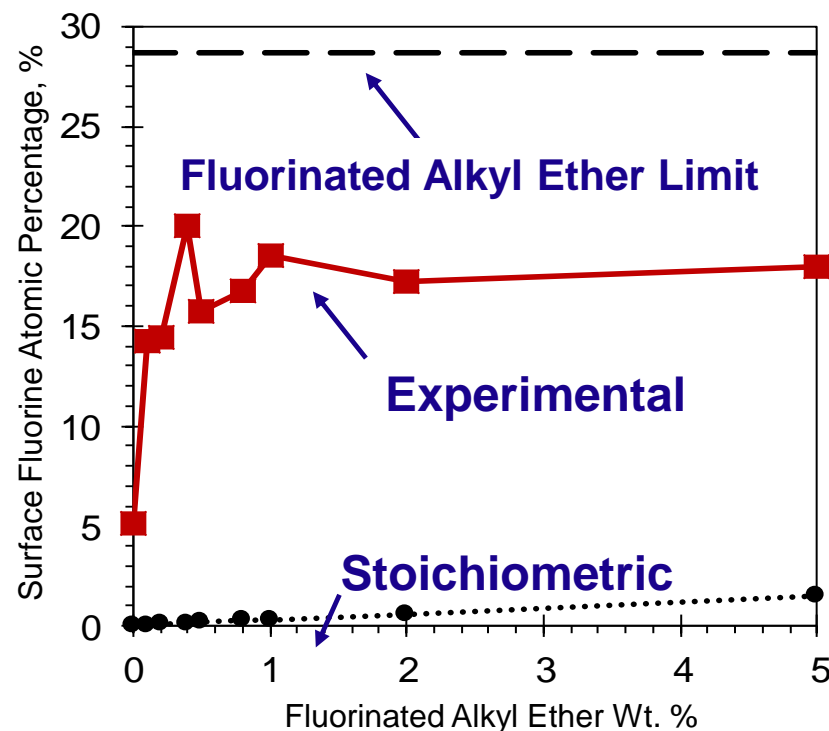
F-containing Polyimides



Si-containing Polyimides



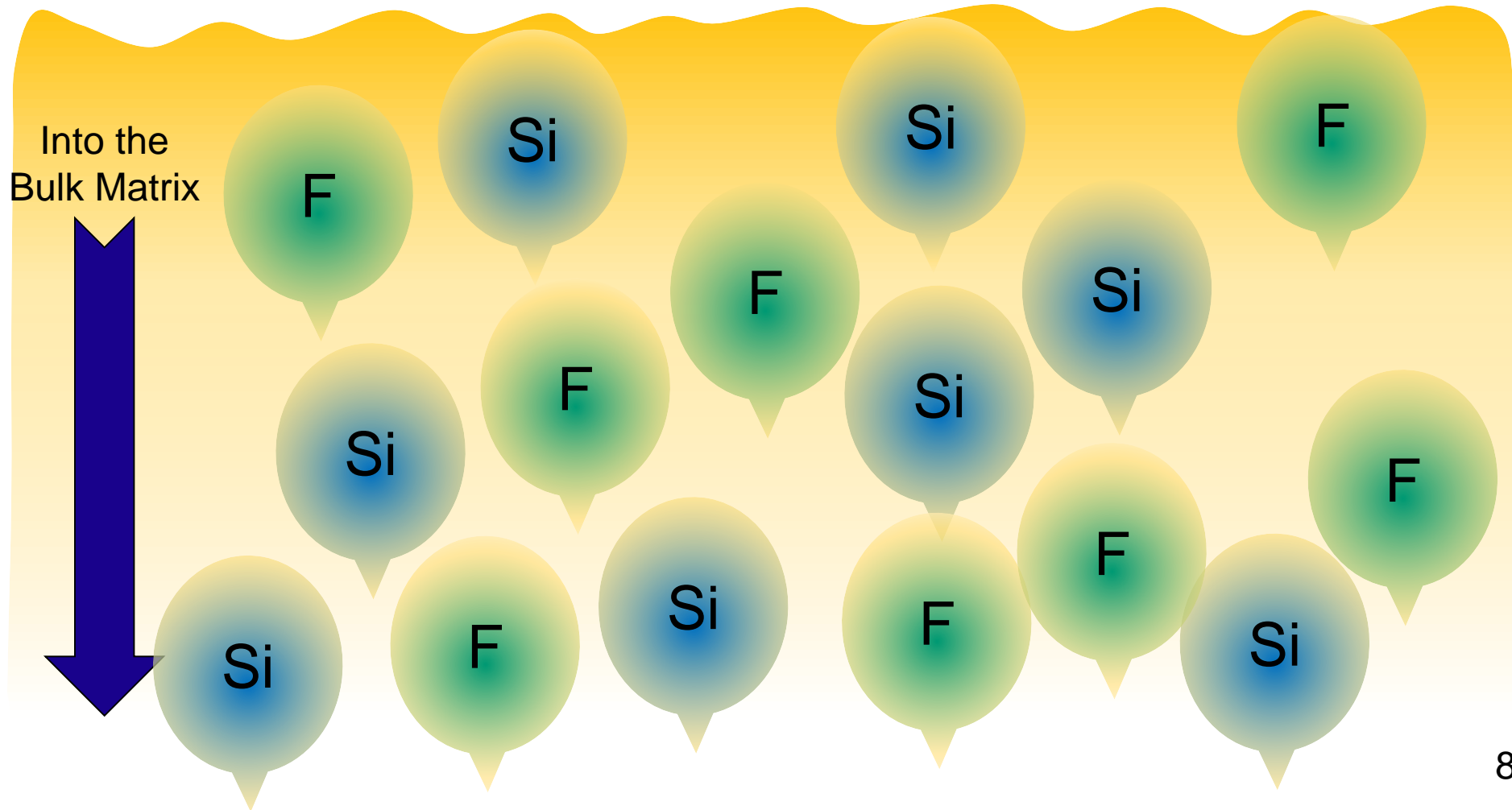
F-containing Polyimides



What Happens when Two SMAs Compete?



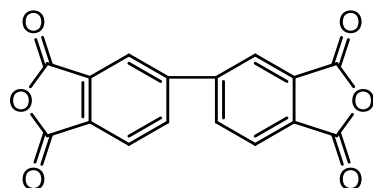
Langley Research Center



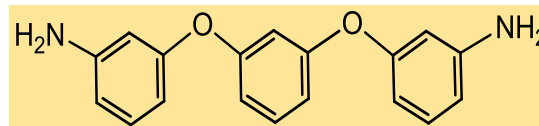
Synthesis of CoPoly(Imide Oxetane Siloxane)-PIOS



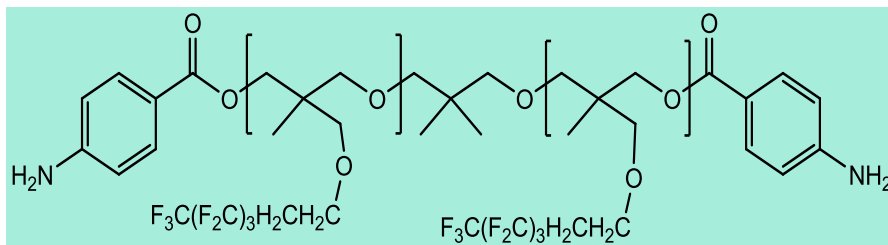
Langley Research Center



s-BPDA

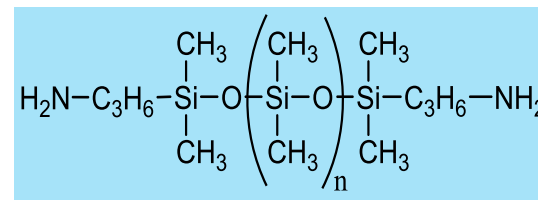


1,3,3-APB



PolyFox7002 (**AEFO**)

MW = 1971 g/mole

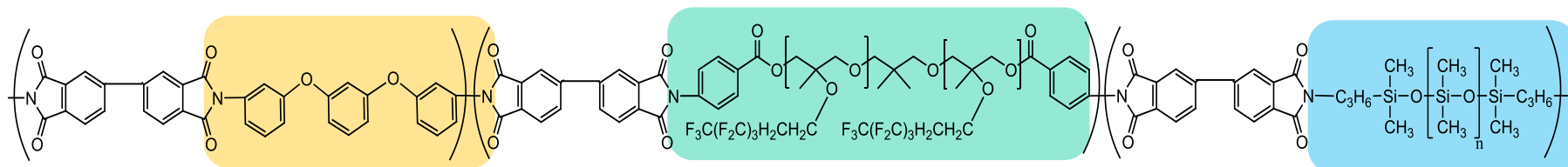


DMS-A11

MW = 1150 g/mole g/mol



DMAc
N₂, Heat

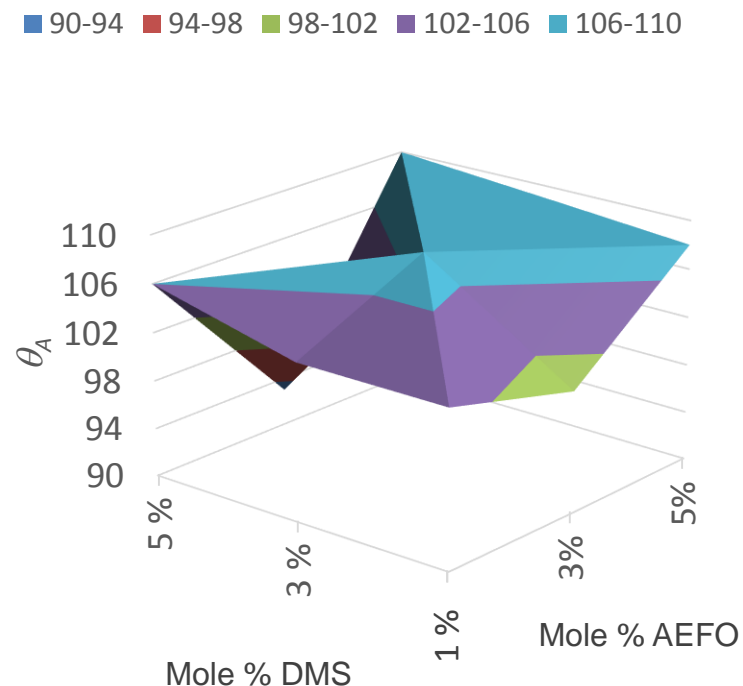


SMA Influence on Contact Angle



Langley Research Center

Designation	Stoichiometric Composition, Mole % of Monomer	Advancing Water Contact Angle, θ_A	
		Air Side	Plate Side
BPDA Control	BPDA and APB	89	90
BPDA-1	5% AEFO, 5% DMS	114	108
BPDA-2	1% AEFO, 1% DMS	103	92
BPDA-3	3% AEFO, 3% DMS	108	98
BPDA-4	5% AEFO, 1% DMS	106	94
BPDA-5	1% AEFO, 5% DMS	108	102
BPDA-6	5% AEFO, 3% DMS	93	120
BPDA-7	3% AEFO, 5% DMS	109	112
BPDA-8	0.5% AEFO, 0.5% DMS	105	117
BPDA-9	3% AEFO, 1% DMS	103	109
BPDA-10	1% AEFO, 3% DMS	100	94

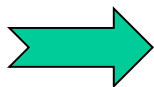


Electron Dispersive Spectroscopy (EDS)



Langley Research Center

Increased
disparity in F
concentration



Increased Si
plate surface
concentration

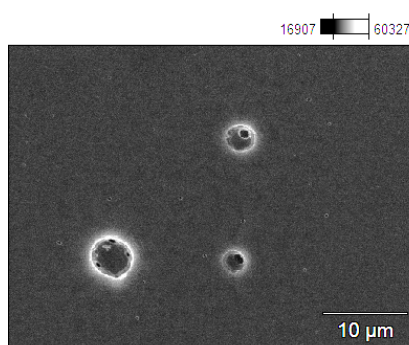


Sample	% AEFO	% Si		C (wt%)	O (wt%)	F (wt%)	Si (wt%)
BPDA-3	3	3	Air	31.8	41.5	13.3	5.0
			Plate	31.0	38.3	16.1	6.7
BPDA-4	5	1	Air	29.2	42.0	18.8	1.6
			Plate	26.2	30.6	35.1	2.2
BDPA-5	1	5	Air	31.9	43.0	9.1	7.3
			Plate	32.2	44.2	8.6	6.4
BPDA-6	5	3	Air	30.7	40.0	15.6	5.2
			Plate	25.6	27.5	36.0	5.1
BPDA-7	3	5	Air	29.6	37.6	17.4	7.5
			Plate	27.4	35.9	18.8	10.7

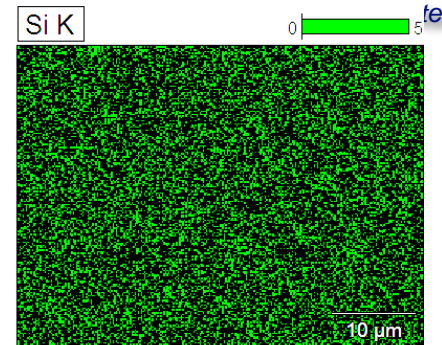
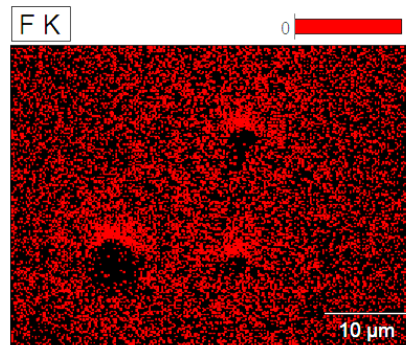
N content varied between 6 and 9%

◆ BPDA-4

- 5% AEFO,
1% DMS

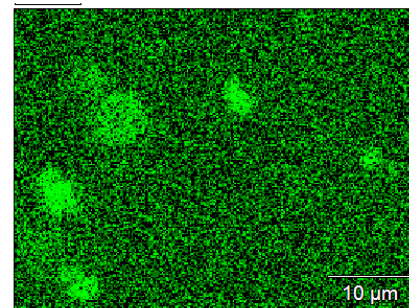
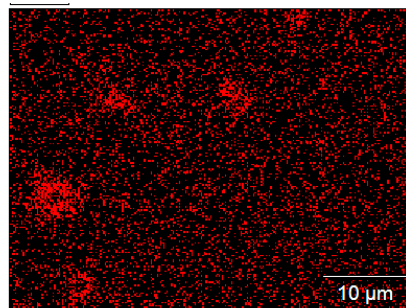
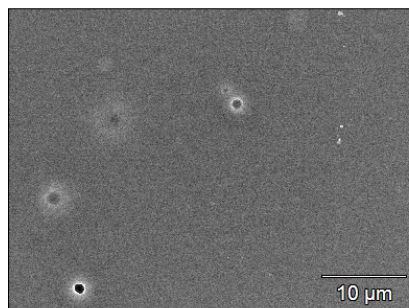


a. BPDA-4 air side



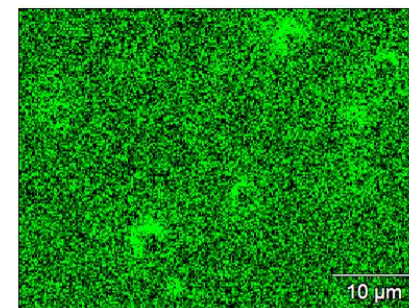
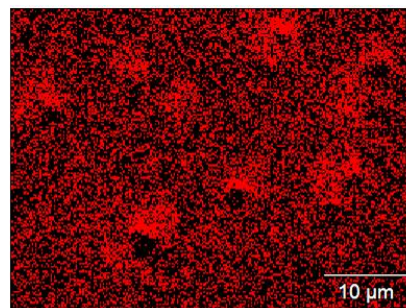
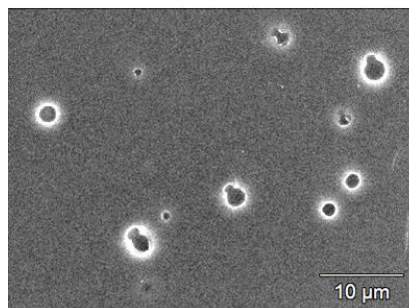
◆ BPDA-5

- 1% AEFO,
5% DMS



◆ BPDA-7

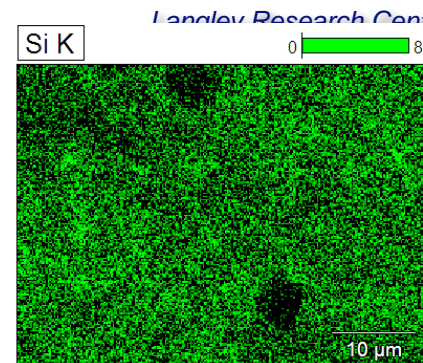
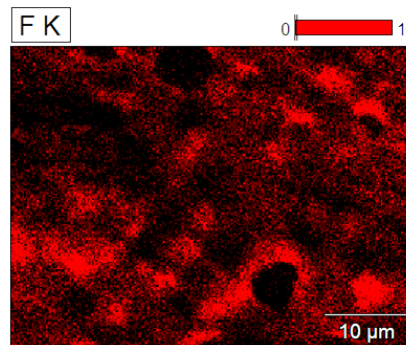
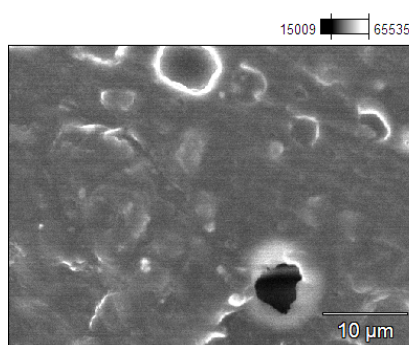
- 3% AEFO,
5% DMS



All % values are mole %
monomer

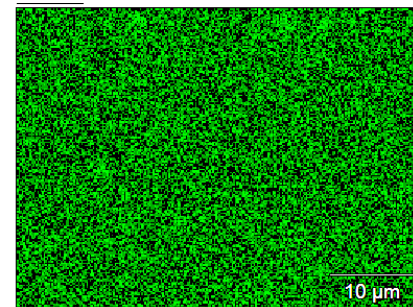
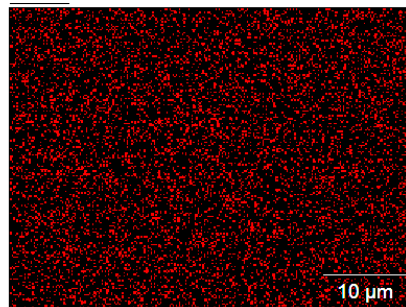
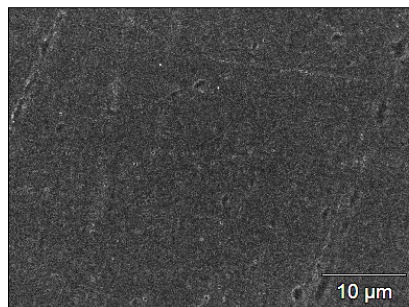
◆ BPDA-4

- 5% AEFO,
1% DMS



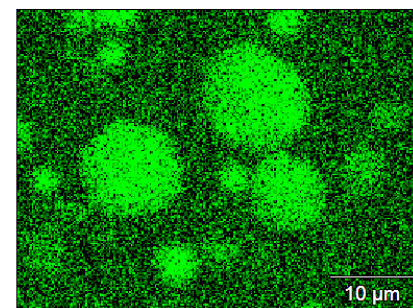
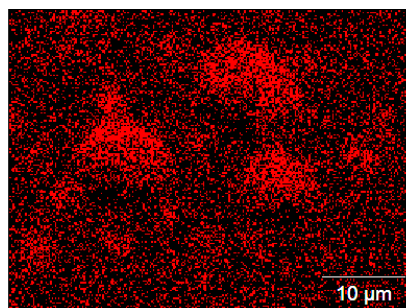
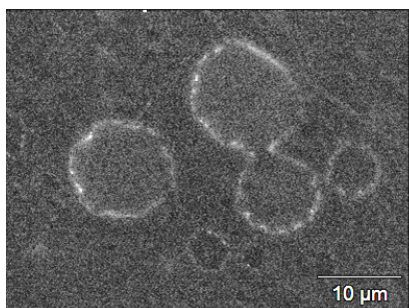
◆ BPDA-5

- 1% AEFO,
5% DMS



◆ BPDA-7

- 3% AEFO,
5% DMS



All % values are mole %
monomer

Obvious AEFO-Mediated Domain Formation

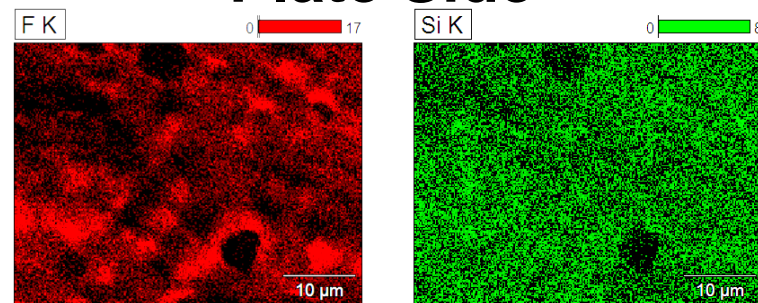
SMA Influence on Contact Angle



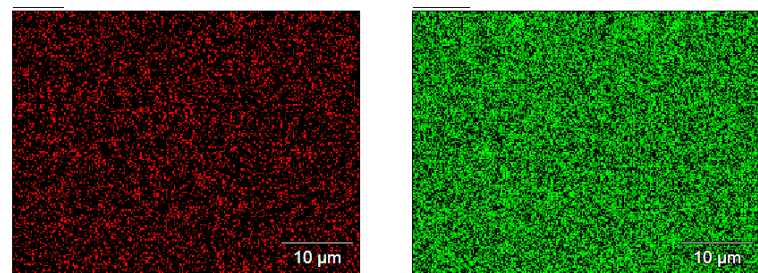
Langley Research Center

Designation	Stoichiometric Composition, Mole % Monomer	Advancing Water Contact Angle, θ_A	
		Air Side	Plate Side
BPDA Control	BPDA and APB	89	90
BPDA-1	5% AEFO, 5% DMS	114	108
BPDA-2	1% AEFO, 1% DMS	103	92
BPDA-3	3% AEFO, 3% DMS	108	98
BPDA-4	5% AEFO, 1% DMS	106	94
BPDA-5	1% AEFO, 5% DMS	108	102
BPDA-6	5% AEFO, 3% DMS	93	120
BPDA-7	3% AEFO, 5% DMS	109	112
BPDA-8	0.5% AEFO, 0.5% DMS	105	117
BPDA-9	3% AEFO, 1% DMS	103	109
BPDA-10	1% AEFO, 3% DMS	100	94

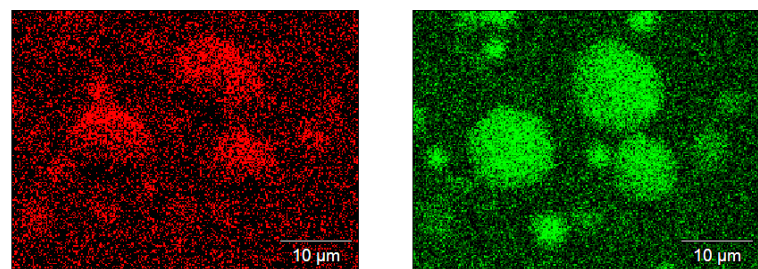
Plate Side



BPDA-4



BPDA-5

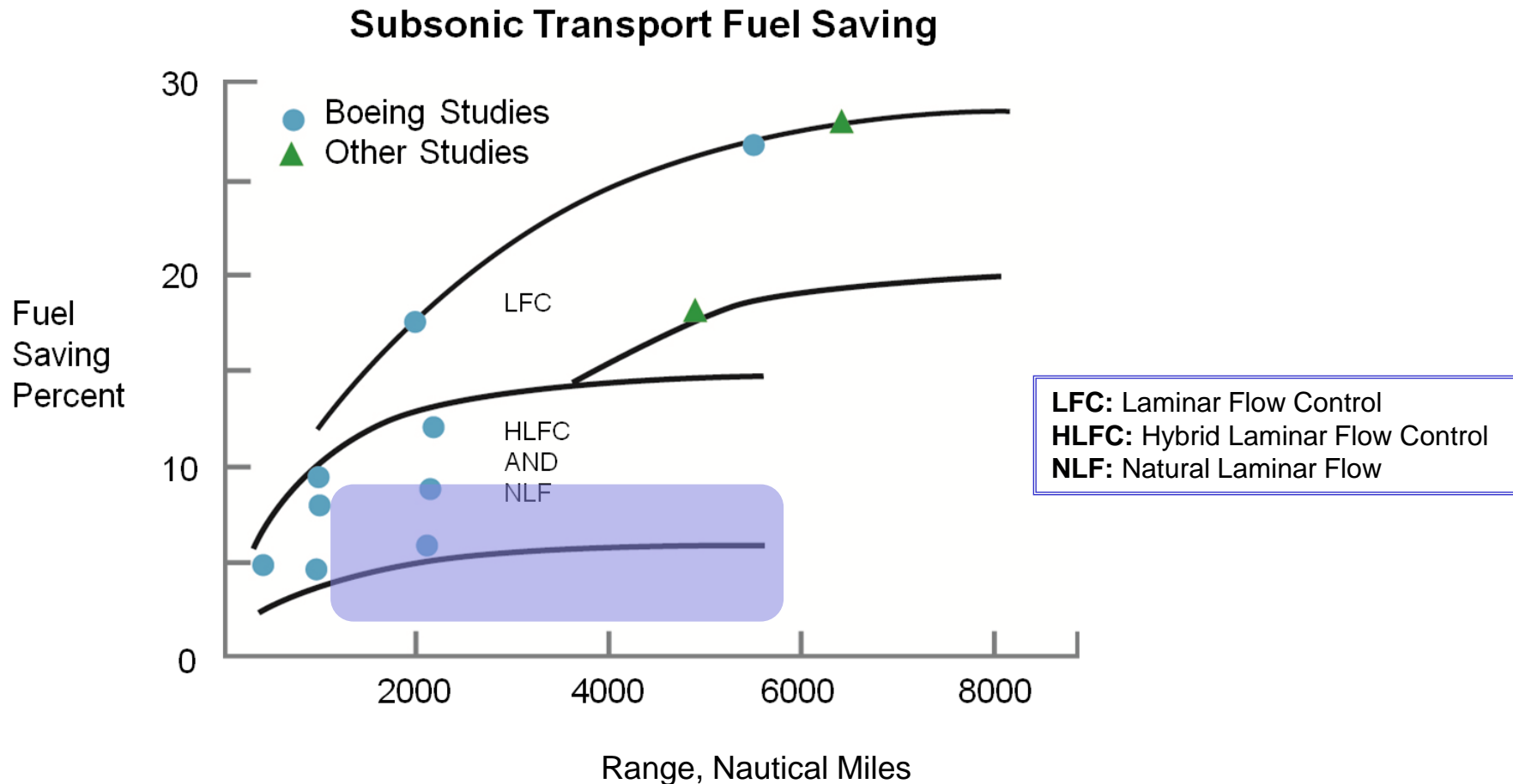


BPDA-7

Natural Laminar Flow Saves Fuel



Langley Research Center



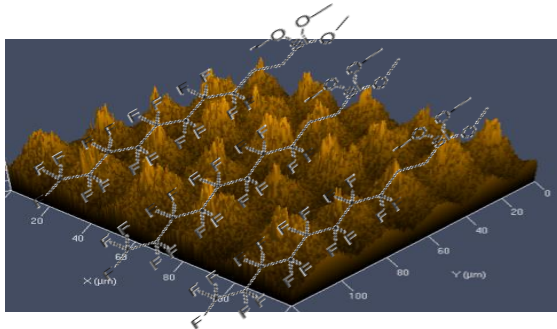
What we know about Insect Adhesion Mitigation ...



Langley Research Center

- ◆ Existing commercial materials are not effective

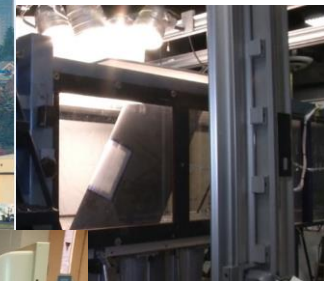
- ◆ Both surface chemistry and surface topography are important



- ◆ Results are dependent on evaluation method



Image from Wikimedia Commons
Not copyright protected





Flightless fruit fly (*drosophila melanogaster*)



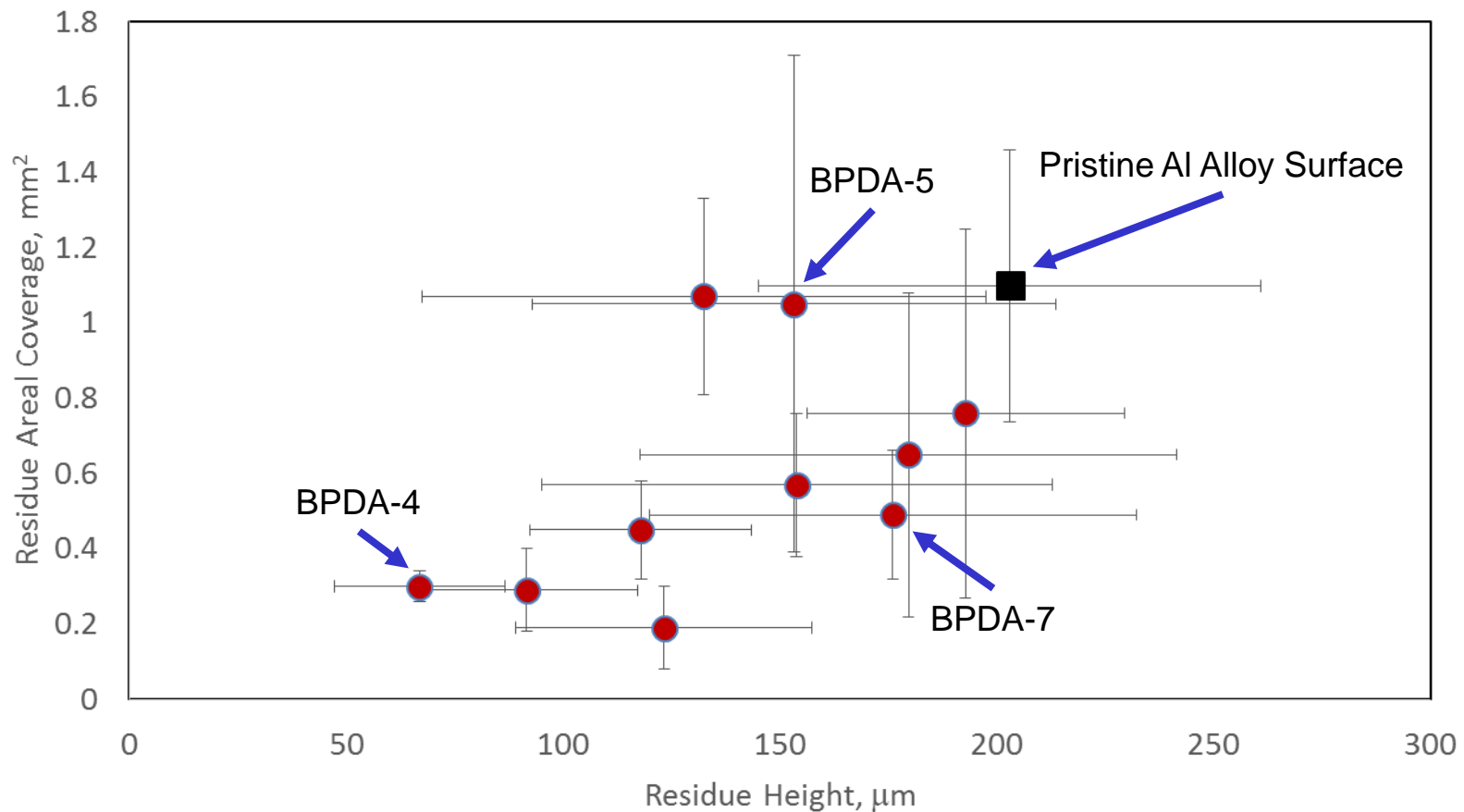
Bench-top Wind Tunnel



Fruit Fly Residue Characterization

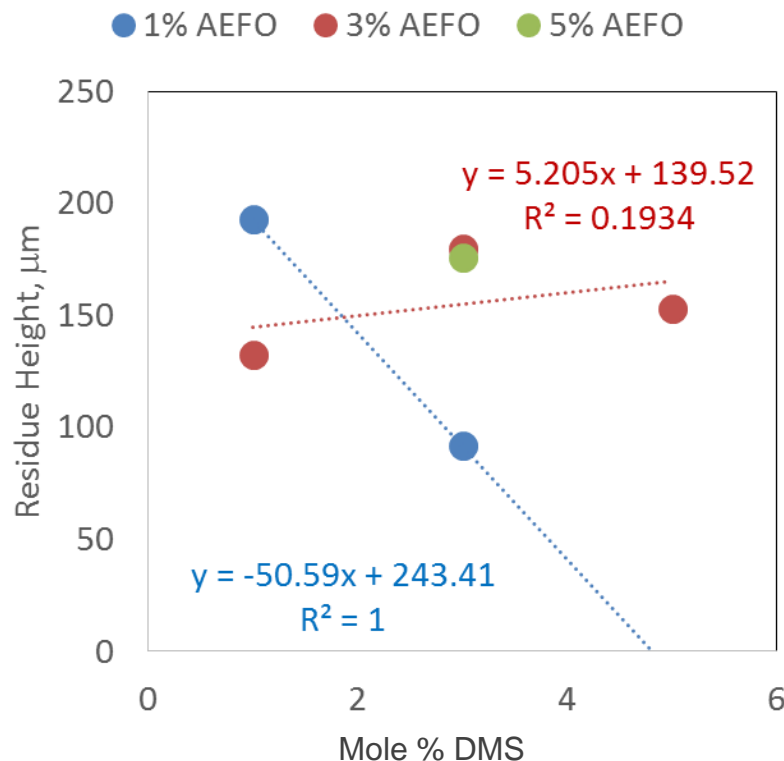


Langley Research Center

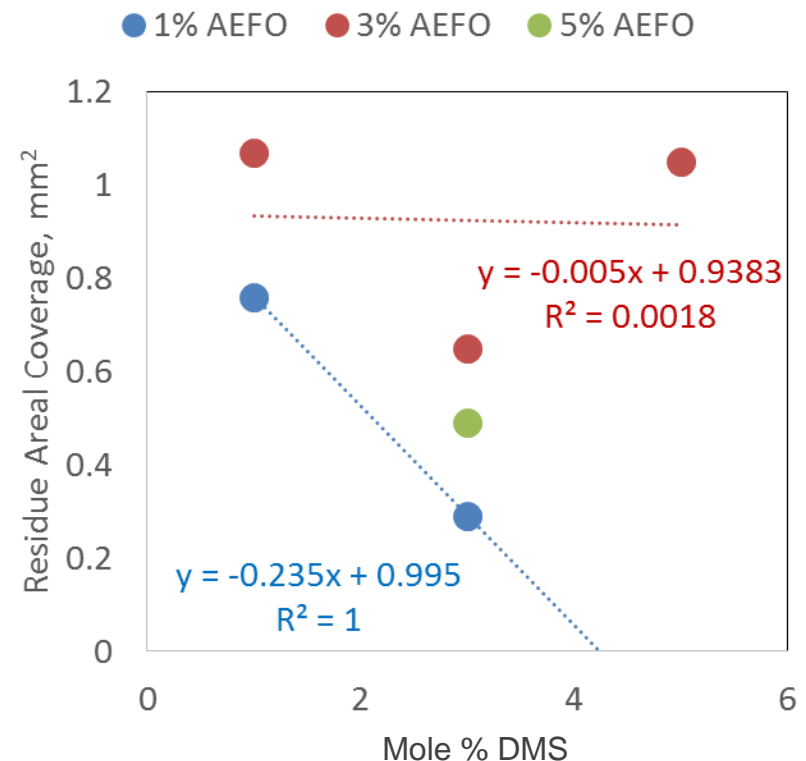


Data collected using a non-contact optical profilometer
(Microprof 100FRT of America)

Residue Height



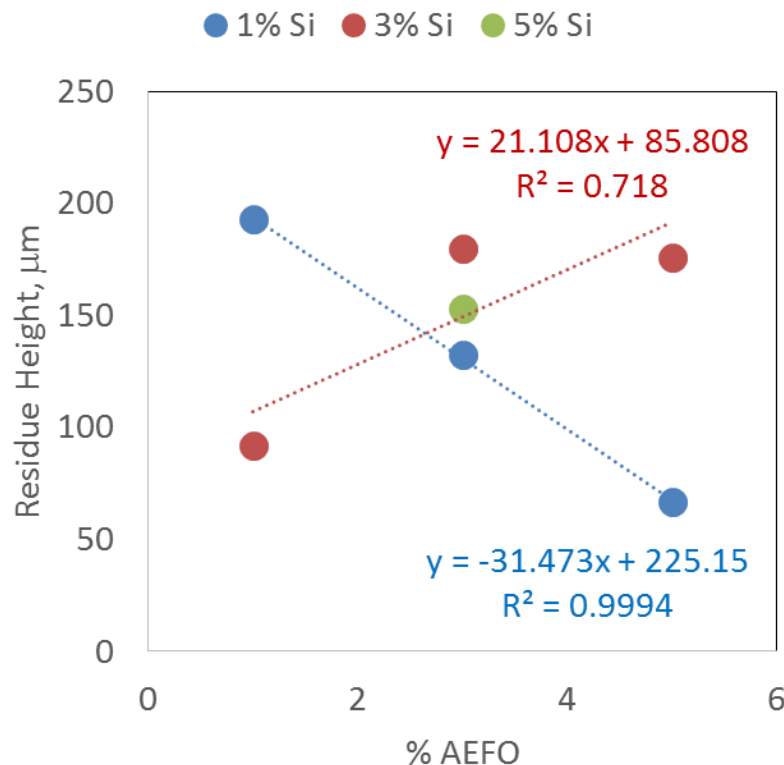
Residue Areal Coverage



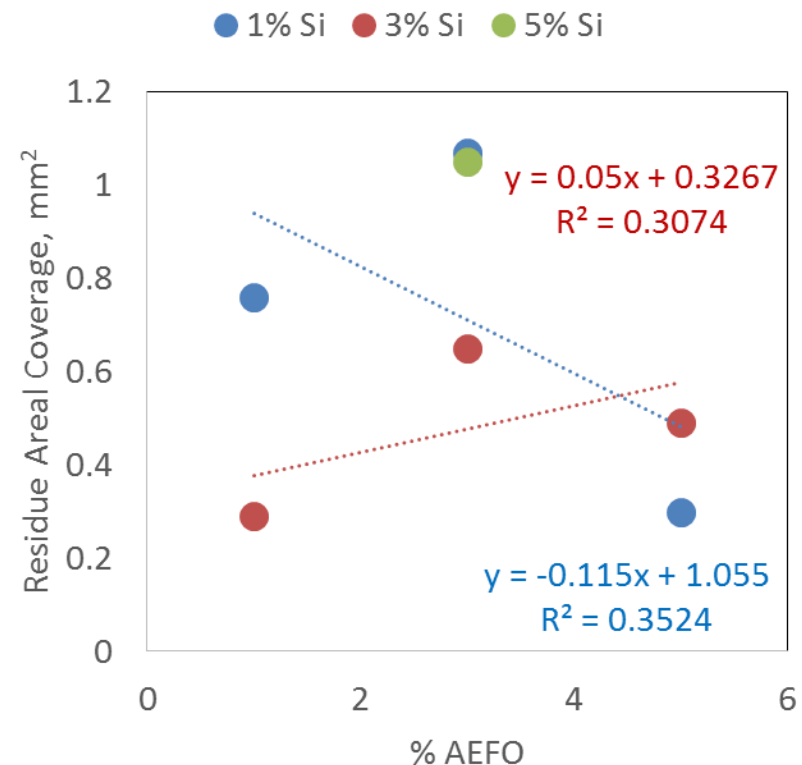
All % values are mole % monomer

Based on available data, no clear dependence of remaining insect residue on Si content variation

Residue Height



Residue Areal Coverage



All % values are mole % monomer

- At low Si content, increased AEFO was **beneficial**
- At increased Si content, increased AEFO was **detrimental**

◆ Summary

- Inclusion of 2 SMAs revealed:
 - Preferential migration of AEFO to the glass side
 - AEFO facilitating DMS surface migration to the glass side
- Differences in θ_A attributed to SMA concentration and copolymer segregation at the surface
- Both SMAs interact to change insect residue adhesion and the net effect is still difficult to ascertain

◆ Future Work

- Explore more AEFO/DMS combinations including lower weight % values
- Collect more insect impact data
- Explore surface mechanical properties as they relate to SMA content

The authors would like to thank:

- Other members of the ERA team: Emilie Siochi, Joseph Smith, Ronald Penner
- Paul Bagby for high speed photography
- The National Institute of Aerospace
- The Langley Aerospace Research Summer Scholars Program
- The ACS Division of Polymer Chemistry

Supplementary Slides

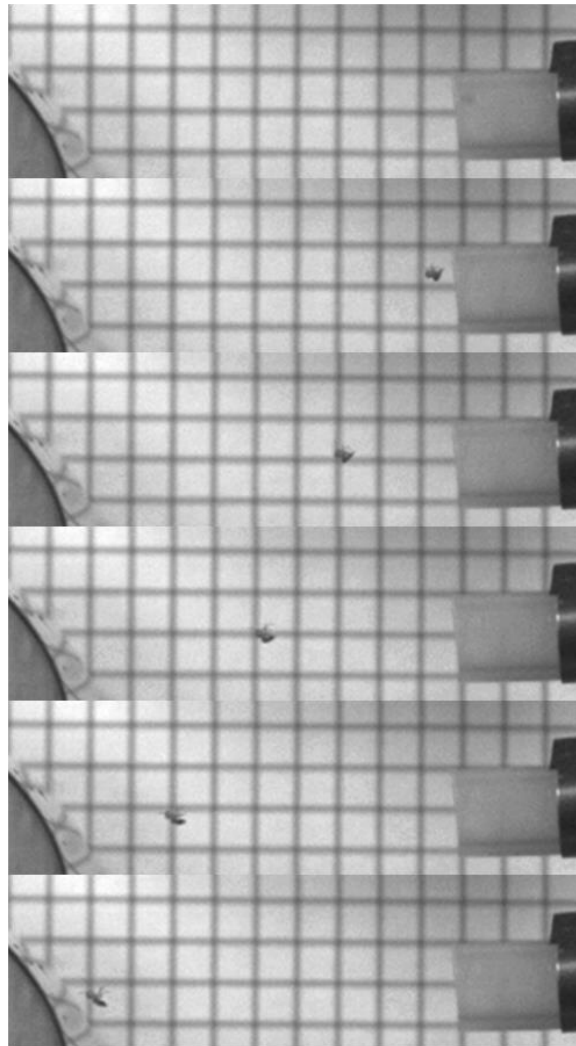


Langley Research Center

Fruit Fly Velocity Determination



Langley Research Center



$t = -60 \mu\text{s}$

$t = 0 \mu\text{s}$

$t = 160 \mu\text{s}$

$t = 300 \mu\text{s}$

$t = 460 \mu\text{s}$

$t = 600 \mu\text{s}$